## JS501-500 Spin Coater

## 500x500 mm Spin Coater

The JS501-500 of large substrate spincoaters is designed for versatility, ease of use and safety in a variety of manual and automated research and development processes. The spincoaters are ideal for processes such as the coating and developing of silicon wafers, glasses, large photomasks, reticles.

- Combined with a spraying nozzle for large area coating
- Easy to be modified for spray coater
- Repeatable performance
- Flexibility for programing
- Auto liquid dispensing system by robot arm Variable moving speed and angle
- 4 different liquids controlled

## Specification

Programmable 20 steps, 20 recipes stored PLC and Touch panel operation Acuracy +- 1 RPM Max RPM: 2,500 Acceleration: 1,000RPM/sec. SUS304 body and bowl for easy cleaning and chemical resistance

Drain port HEPA filter unit Max 500x500mm, 1T glass

Standard dry vacuum pump: 100 liter/ min, 0.5 ATM

Standard sample chuck

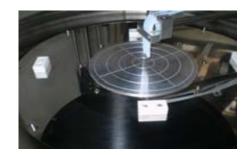
Dimension 1700W x 1400D x 1650H mm

220VAC, 60Hz, 25 amp

Weight: 300 Kg









JAESUNG JS401 SPIN COATING SYSTEM